# Phase Shifter for <br> Remote Controllable <br> VTO Alternate 

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## Motivation

- The VTO (variable tap-off) allows custom pair-wise tailoring of power distribution along cryomodules. It has been successfully tested and incorporated in the RF PDS for the ILCTA-NML at Fermilab.
- While mass production in industry would greatly reduce the VTO cost, making a few at a time at SLAC has been quite expensive ( $\sim \$ 30 \mathrm{~K}$ each).
- Readjusting the power distribution requires physically accessing the VTO's and depressurizing the waveguide line. It would not be easy, nor cheap, to make the VTO remote-controllable.

An alternate concept is presented which

- makes maximal use of commercially available parts and
- is remote-controllable.

It incorporates a simple, well-matched phase shifter.

## Tailoring Power Distribution with Pase Shifters and Magic-Tees



$$
\begin{gathered}
E_{2}=\frac{1}{\sqrt{2}} e^{i \phi_{2}} \quad \begin{array}{l}
\text { If } \phi_{1} \text { and } \phi_{2} \text { are changed in opposite } \\
\text { senses by half the desired } \Delta \phi, \\
\text { the coupled and through phases are } \\
\text { unaffected as the amplitudes are adjusted. } \\
\left.\left.\frac{E_{1}}{\sqrt{2}}-\frac{E_{2}}{\sqrt{2}}\right)=\frac{1}{2}\left(e^{i \phi_{1}}-e^{i \phi_{2}}\right)=\frac{e^{i\left(\phi_{2}+\phi_{1}\right) / 2}}{2}\right)^{2}\left(e^{-i\left(\phi_{2}-\phi_{1}\right) / 2}-e^{i\left(\phi_{2}-\phi_{1}\right) / 2}\right)
\end{array}
\end{gathered}
$$

## Required Phase Range



If we add $-90^{\circ}$ phase length in path one, the required range of $\Delta \phi$ shifts to $-90^{\circ}-90^{\circ}$, and we see that the phase shifters need only range between $\underline{0^{\circ}}$ and $90^{\circ}$.

$$
E_{e}=e^{i\left(\frac{\phi_{1}+\phi_{2}}{2}+\frac{\pi}{4}\right)} \sin \left(\frac{\Delta \phi}{2}+\frac{\pi}{4}\right) \quad \begin{array}{lllll}
\underline{\underline{E_{e}}} & \underline{\phi}_{1} & \underline{\phi}_{2} & \underline{\Delta \phi} \\
0 & 90^{\circ} & 0^{\circ} & -90^{\circ} \\
E_{t}=e^{i\left(\frac{\phi_{1}+\phi_{2}}{2}-\frac{\pi}{4}\right)} \cos \left(\frac{\Delta \phi}{2}+\frac{\pi}{4}\right) & 1 / 3 & 50^{\circ} & 30^{\circ} & -30^{\circ} \\
1 / 2 & 45^{\circ} & 45^{\circ} & 35.265^{\circ} & -19.47^{\circ} \\
1 & 0^{\circ} & 0^{\circ} \\
& 1 / 0^{\circ} & 90^{\circ}
\end{array}
$$

## Possible Configurations

in-line phase shifters

reflections too large for main line (up to -23 dB for DESY/SPA Ferrite design, fine in feeds buffered by circulators)

bulky \& complicated; possible large reflections if shorts don't track

## Available Phase Shifters




SPA Phase Shifter 008



MEGA Ind.
Impedance Matcher
available design not pressurizable

## Trombone Phase Shifter



- takes advantage of required U-bends;
- match ideally unaffected by position;
- no bellows


## RF Design



## The Gap Problem

$\sim 1.91 \%$ is coupled into the 0.083 " gap, with very little reflection.




Non-negligible power couples into gap between moving waveguide and outer walls.
The excited gap mode has different wavelength than the interior waveguide mode.
Gap is connected to open volumes that change as phase shifter is moved.
Potential gap resonances can ruin match, absorb power, and cause breakdown.

## Fingers



Cutting off the gap with springy finger stock along the top and bottom should suffice.

No longitudinal currents along side walls.


Beryllium copper not acceptable for safety reasons; potential rf breakdowns could produce beryllium dust.

## Test of Effect of Fingers Along Top and Bottom of Waveguide Insert



## High-Power Test of Waveguide Insert



No breakdown from device under test, 8 breakdown from waveguide

## Conceptual Mechanical Design



## Another Idea Considered



